

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

SCHWAB ET AL

Serial Number: 09/764,634

Group Art Unit: 1765

Filed: January 18, 2001

For: PROCESS FOR PRODUCING A SEMICONDUCTOR WAFER

Information Disclosure Statement

Honorable Commissioner of Patents and Trademarks  
Washington, D.C. 20231

Sir or Madam:

I, Wolfgang Staudacher, associated with the preparation and prosecution of the above-identified application, residing at Seebauerstraße 4, 81735 München, Germany, wish to call the attention of the Patent Examiner to the references enumerated on the enclosed PTO Form-1449.

I believe the documents enumerated on the enclosed Form PTO-1449 and attached thereto, are cited in the enclosed application and in the Office Action of the German Patent and Trademark Office and may be material to the examination of the application.

Therefore, it is respectfully requested that the foregoing Information Disclosure Statement be considered by the Examiner and incorporated into the file of this application.

I wish to comment as follows concerning the prior art references enumerated on PTO Form-1449:

US 5,451,267 is already in English language.

EP 0 673 545 is already in English language.

EP 0 930 640 is already in English language.

US 5,474,644 is already in English language.

Patent Abstract of Japan, corresponding to JP 62-81031, is already in English language.

FORM PTO-1449  
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO. :

SERIAL NO.

09/764,634

APPLICANT :

## LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

FILING DATE

January 18, 2001

GROUP

1765

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AL							
	AM							
	AN							
	AO							
	AP							

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR		
	AS		
	AT		

EXAMINER

DATE CONSIDERED

EXAMINER'S NOTE: This reference is cited where it is believed to be pertinent to the invention claimed in this application and is hereby cited in accordance with the provisions of 35 U.S.C. 102(b).

Patent Abstract of Japan, corresponding to JP 62-132325, is already in English language.

Signed this       day of March, 2001

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Dr. Wolfgang Staudacher